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Dated: June 7, 2004

Signature

(Raymond Garguilo, Jr.)

Docket No.: TESSERA 3.0-272
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of :
Delin Li :
Application No.: 10/611,390 : Group Art Unit: 2818
Filed: July 1, 2003 : Examiner: Mai Huong C.
For: ASSEMBLIES HAVING STACKED : Tran
SEMICONDUCTOR CHIPS AND METHODS :
OF MAKING SAME :
Commissioner for Patents

P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE

Dear Sir:

In response to the Official Action mailed May 7, 2004, the applicant hereby elects Group I, namely claims 1-24, for examination in the present application. Applicant submits remarks to this election.